Tengda

List of Publications by Year in descending order

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2258059 2550090 3 89 3 3 citations h-index g-index papers 3 3 3 64 citing authors docs citations times ranked all docs

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#	Article	IF	CITATIONS
1	Improvement in chemical mechanical polishing of 4H-SiC wafer by activating persulfate through the synergistic effect of UV and TiO2. Journal of Materials Processing Technology, 2021, 295, 117150.	6.3	38
2	Corrosion control of copper wiring by barrier CMP slurry containing azole inhibitor: Combination of simulation and experiment. Colloids and Surfaces A: Physicochemical and Engineering Aspects, 2020, 599, 124872.	4.7	44
3	Role of 1,2-benzisothiazolin-3-one (BIT) in the Improvement of Barrier CMP Performance with Alkaline Slurry. ECS Journal of Solid State Science and Technology, 2019, 8, P449-P456.	1.8	7